Docket No.

241280US2S DIV

IN RE APPLICATION OF: Tsutomu SATO et al.

SERIAL NO: 10/637,665

FILED:

August 11, 2003

FOR:

SEMICONDUCTOR DEVICE FORMED IN SEMICONDUCTOR LAYER ARRANGED ON SUBSTRATE WITH ONE OF INSULATING FILM AND CAVITY INTERPOSED BETWEEN THE SUBSTRATE AND THE

SEMICONDUCTOR LAYER

COMMISSIONER FOR PATENTS ALEXANDRÍA, VIRGINIA 22313

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*RESPONSE UNDER 37 CFR 1.116-EXPEDITED PROCEDURE EXAMINING

GROUP_28/8

SIR:

Transmitted herewith is an amendment under 37 C.F.R. § 1.116 in the above-identified application.

- No additional fee is required
- ☐ Small entity status of this application under 37 C.F.R. §1.9 and §1.27 is claimed.
- ☐ Additional documents filed herewith:

The Fee has been calculated as shown below:

CLAIMS	CLAIMS REMAINING		HIGHEST NUMBER PREVIOUSLY PAID	NO. EXTRA CLAIMS		RATE		CALCULATIONS
TOTAL	3	MINUS	20	0	x \$50 =		=	\$0.00
INDEPENDENT	1	MINUS	3	0	х	\$200	=	\$0.00
		☐ MULTIPLE DEPENDENT CLAIMS				\$360	=	\$0.00
		TOTAL OF ABOVE CALCULATIONS						\$0.00
		☐ Reduction by 50% for filing by Small Entity					\$0.00	
	*, 00	☐ Recordation of Assignment				\$40	_	\$0.00
						TO	ΓAL	\$0.00

Щ	Α	check	in	the	amount	of	' \$0. 00 i	s attacl	ned.
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- ☐ Credit card payment form is attached to cover the fees in the amount of **§0.00**
- Please charge any additional Fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.
- If these papers are not considered timely filed by the Patent and Trademark Office, then a petition is hereby made under 37 C.F.R. §1.136, and any additional fees required under 37 C.F.R. §1.136 for any necessary extension of time may be charged to Deposit Account No. 15-0030. A duplicate copy of this sheet is enclosed.

OBLON, SPIVAK, McCLELLAND, MAIER & NEUSTADT, P.C.

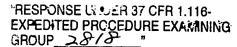
Customer Number

Tel. (703) 413-3000 Fax. (703) 413-2220 (OSMMN 05/03) I:\ATTY\RFF\24s\241280\241280US-AF-CVR.DOC Eckhard H. Kuesters

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Remus F. Fetea, Ph.D.

Limited Recognition No. L0037





IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF

:

TSUTOMU SATO ET AL.

: EXAMINER: NGO, N. V.

SERIAL NO: 10/637,665

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FILED: AUGUST 11, 2003

: GROUP ART UNIT: 2818

FOR: SEMICONDUCTOR DEVICE

FORMED IN SEMICONDUCTOR

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SUBSTRATE AND THE SEMICONDUCTOR LAYER

AMENDMENT UNDER 37 C.F.R. § 1.116

COMMISSIONER FOR PATENTS ALEXANDRIA, VIRGINIA 22313

SIR:

In response to the Office Action dated August 3, 2005, please amend the aboveidentified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 3 of this paper.